Plasma sources for laser- and beam-driven plasma accelerators

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- Félicie Albert, Lawrence Livermore National Laboratory
- Brigitte Cros and Thomas Audet, Université Paris-Sud
- Jérôme Faure, CNRS & Ecole Polytechnique
- Spencer Gessner, SLAC (now at CERN)
- Leo Gizzi & Paolo Tomassini, INFN, Pisa
- Mark Hogan, SLAC
- Dino Jaroszynski, University of Strathclyde
- Andi Maier, University of Hamburg & CFEL, DESY
- Patric Muggli, Max-Planck-Institut f
 ür Physik
- Jens Osterhoff and Lucas Schaper, DESY
- Matthew Streeter, Lancaster University









- What would we like the plasma source to do?
- An overview of existing sources
- Challenges and conclusions







What would we like?

Common requirements

- Well-defined & controllable density
- Some degree of longitudinal uniformity
- Reproducibility
- Long operating lifetime
- Controllable transverse profile? (e.g. hollow channel)
- Accessible to diagnostics
- Limited gas load to rest of system
- Minimization of unwanted secondary beam generation (e.g. bremsstrahling)
- Others ...?

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Laser-driven

- Sharp entrance/exit boundaries
- Possibly, laser guiding
- Possibly, control of longitudinal profile ("tapering")
- Others ...?





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Beam-driven

 Possibly, provision of laser pulse for ionization



Gas jets





- Plasma density controlled by varying backing pressure behind jet -
 - 10 100 bar depending on nozzle diameter and desired density
- *n*_e typically 10¹⁷ 10²⁰ cm⁻³
- Length typically few mm
- Supersonic nozzles provide near-flat-top density profile & sharper boundaries









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Gas jet: kHz laser-driven accelerator



Thanks to: J. Faure (LOA, Ecole Polytechnique)

- Low pulse energy ⇒ tight focus, short length
- High rep-rate ⇒ small mass flow required
- Gas jet:
 - nozzle dia. < 100 μm
 - Sharp boundaries to avoid refraction







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- Sharper gradients
- Higher n_e above 100 µm (less nozzle damage)



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Gas jets give good diagnostic access

Thanks to Stuart Mangles, Imperial College London







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 Control of longitudinal profile possible by introducing blades and/or additional gas sources:

ohn Adams Institute for Accelerator Science

- K. Schmid *et al. PRSTAB* **13** 091301 (2010).
- M. Hansson et al. PRSTAB 18 071303 (2015).
- C. Thaury *et al. Sci. Rep.* **1** 16310 (2015).
- E. Guillaume *et al. PRL* **115** 155002 (2015).



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Gas cells



Gas cells

- Region of uniform neutral gas contained by differential pumping through coaxial pinholes
- Density fairly uniform between pinholes...
 - but plume of gas from front and back of cell
- Density easily adjusted by controlling gas flow
 - but erosion of pinholes will change density
- Several groups have designed variable length gas cells







Examples of gas cells

Thanks to: Stefan Karsch Munich Centre for Advanced Photonics





OpenFoam simulations show uniform density within cell & extent of plumes









Disposable gas cells

 Gas cell made by 3D printing





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- Highly homogeneous region between gas slots
- No shocks or turbulence
- Reproducible when pulsed
- Low gas load at continuous flow
- Reduces turbulence caused by nonreproducible gas valve









A gas cell for a beam-driven accelerator



Thanks to: J. Osterhoff & L. Schaper, DESY

FLASHForward experiment

Design requirements:

- No emittance spoilers
- Full transverse (optical) probing
- Supporting multiple injection scenarios
- Easily replaceable (8h)
 - Limited access to FLASH2 tunnel
 - No contamination of FLASH vacuum
- Plasma density
 - Acceleration: up to 5 x 10¹⁷ cm⁻³
 - Injection: up to 5 x 10¹⁸ cm⁻³





A gas cell for a beam-driven accelerator





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A gas cell for a beam-driven accelerator





Thanks to: J. Osterhoff & L. Schaper, DESY

FLASHForward experiment

Target concept:

- Laser ionized
- Gas filling
 - Separate pressure control
 - Multiple species operation
 - Localised density peak and downramp possible
- Continuous gas flow design
 - No windows required
 - Compatible with FLASH vacuum standards
- Transverse access







- Maximum continuous gas flow of
 20 mbar l/s hydrogen into main chamber
 - at beamline intersection to FLASH2 pressure has to be < 10-8 mbar
 - additionally to main chamber 3 differential pumping sections in beam-line
 - efficient for pumping: small diameter pipes, bending magnet

Pumping speeds required:

- Experimental chamber:
 - 2500 l/s turbo pump, 450 m3/h backing pump
- First stage:
 - 600 l/s turbo pump, 35m3/h backing pump
- Second stage:
 - 600 l/s turbo pump, 35m3/h backing pump
- Third stage:
 - 450 l/s turbo backed by 300l/s turbo, 35m3/

h backing pump



Heat-pipe ovens & similar



Many <u>beam-driven</u> plasma accelerators require:

- Long targets (metre scale)
- Relatively low density $n_e = 10^{14} 10^{16} \text{ cm}^{-3}$
- Ionizable by drive beam or a laser pulse (\Rightarrow low-Z target)
- Minimize ionization by collisions with driver (\Rightarrow low-Z target)
- In some cases, high uniformity





FACET Experiments Use Meter Scale Plasmas: Laser or Beam Field Ionization, Alkali Metal Vapour or Hvdrogen Gas





AWAKE plasma source

Source requirements

- ▶ $10^{14} \le n_e \le 10^{15} \text{ cm}^{-3}$ ($k_p \sigma_r ≈ 1$)
- > $\Delta n_{\rm e} < 0.2\%$ (SSM & acceleration)
- Length several metres
- Few cm ramp (electron trapping)
- Seed for self-modulation



Thanks to: P. Muggli (MPP), E. Oz (MPP), F. Batsch (MPP), F. Braunmuller (MPP), R. Kersevan (CERN), G. Plyushchev (CERN/MPP/EPFL), J. Moody, M. Huether, MPP, V. Fedosseev, F. Friebel, CERN

Rb vapour source (not heat-pipe oven)

- $h_{e} = n_{Rb}$
- Laser ionized
 - EI = 4.177 eV
 - *I*_{th} = 1.7 × 10¹² W cm⁻²
- Impose very uniform T
 - $\delta n_{Rb} / n_{Rb} = \delta T / T < 0.2\%$
- ▶ 160 °C ≤ T ≤ 220 °C for $10^{14} \le n_{Rb} \le 10^{15}$ cm⁻³
- Control Rb gradient with Rb source temp
- Short scale length: heat-pipe design
- n_{Rb} measured at each end by white light

interferometry Simon Hooker University of Oxford EAAC, Elba, 24 - 30 Sep 2017











Plasma sources with controlled transverse profile

Why is control of transverse profile important?

- For LWFA, guiding of the drive pulse
- Transverse variation of n_e:
 - Causes phase differences between on- and off-axis wake oscillations
 - Affects relation between accelerating and focusing phases
 - N. E. Andreev et al. PoP 4 1145 (1997)
- Hollow plasma channels
 - Have uniform acceleration gradients, independent of transverse profile of driver
 - Weak, linear focusing forces
 - T. C. Chiou & T. Katsouleas PRL 81 3411 (1998)
 - C. B. Schroeder et al. PRL 82 1177 (1999)
- Near-hollow channels
 - Independent control of focusing & accelerating forces
 - C. B. Schroeder *et al. PoP* **20** 080701 (2013).







FACET: Generation of hollow plasma channels





- High-order Bessel beam formed by kinoform
- Ionizes Li vapour in heat-pipe to form annular plasma (with unionized gas on axis)

Thanks to: S. Gessner

(SLAC, now @ CERN)

- Ti:sapphire laser: 34 mJ, 100 fs
- $n_{\rm Li} = 8 \times 10^{16} \, {\rm cm}^{-3}$
- Oven 130 cm long



EACET: Generation of hollow plasma channels





Thanks to: S. Gessner (SLAC, now @ CERN)

- Method extended to gas cells
 - Direct observation of channel profile
 - Can use a high-charge drive beam without field ionization by beam
- But...
 - Gases more difficult to ionize
 - Self-phase modulation can affect laser pulse





Waveguides

Accelerating field : $E_z \propto \omega_p \propto \sqrt{n_e}$ Dephasing length : $L_d \approx \frac{\lambda_p^3}{\lambda^2} \propto \frac{1}{n_e^{3/2}}$ Energy gain : $\Delta W = E_z L_d \propto \frac{1}{n_e}$

- Laser-driven plasma accelerators need the driving pulse to be guided since Rayleigh range is typically only few mm
- Relativistic and ponderomotive effects greatly increase interaction length without external waveguide
- Waveguides come in two types:
 - Step-index waveguides (hollow capillaries)
 - Gradient refractive waveguides: Plasma channels







Step-index: hollow capillaries



Operation in a large parameter range:

- Inner diameter: 50 500 μm,
- Glass walls: optically smooth
- Length : limited by laser damping length (several meters for 100µm diameter capillary)
- Laser intensity: the main limitations are due to poor beam quality and stability
- Gas : H2 to control the density easily (laser ionisation)
- ▶ Gas pressure control: 0-500 mbar, pulsed (1shot /10s).





Hollow capillaries: Progress

Thanks to: Brigitte Cros & Thomas Audet LPGP, CNRS-Université Paris-Sud





- Stable gas confinement (measurement by interferometry and fluid simulations)
 - J. Ju et al. J. Appl. Phys. **112** 113102 (2012)
- Laser wakefield acceleration in capillary tubes to ~ 300 MeV:
 - J. Ju *et al. Phys Plasmas* **20** 083106 (2013). F. G. Desforges *et al. Nucl. Instr. Meth. A* **740** 54 (2014)
 - M. Hansson et al. Phys. Rev. STAB **17** 031303 (2014).
- Use of capillary exit as pinhole for imaging of radiation and diagnostic of electron acceleration:
 - J. Ju *et al. Phys. Plasmas* **20** 083106 (2013)
 - J. Ju et al. Phys. Rev. STAB **17** 051302 (2014)





Hollow capillaries: Progress









 Simulations show acceleration of externallyinjected electrons up to 10 GeV



Gradient refractive index guiding









Gradient refractive index guiding

Laser beam will be focused if the refractive index decreases with distance from axis



- Plasma channel: transverse variation of ^x electron density gives correct refractive index profile
- Lowest-order mode of parabolic channel is Gaussian...
- ... but shape of channel is not very important: matched spot size mainly determined by channel depth.
 - See Durfee *et al. Opt. Lett.* **19** 1937 (1994)

 $\eta = \sqrt{1 - \left(\frac{\omega_p}{\omega}\right)^2}$ $\approx 1 - \frac{1}{2} \frac{n_e(r)e^2}{\gamma m_e \epsilon_0 \omega^2}$ Parabolic channel: $n_e(r) = n_e(0) + \Delta n_e \left(r/r_{ch}\right)^2$ $W_M = \left(\frac{r_{ch}^2}{\pi r_e \Delta n_e}\right)^{1/4}$





Plasma channels generated by discharges



Imperial College, London





- Open discharges
 - N. C. Lopes et al. *Phys Rev E* 68 035402 (2003).
 - R. Bendoyro, at al., *IEEE Trans. Plasma* Science 36 1729 (2008)
- Ablated capillary discharges
 - Y. Ehrlich et al. *Phys Rev Lett* **77** 4186 (1996).
 - D. Kaganovich *et al. Phys Rev E* **59** R4769 (1999).
 - D. Kaganovich *et al. Appl. Phys. Lett.* **78** 3175 (2001).
- Gas-filled capillary discharges
- Fast capillary discharges
 - Hosokai *et al. Opt Lett* **25** 10 (2000).





Gas-filled capillary discharge waveguides







Evolution of plasma channel during discharge pulse







Gas-filled capillary discharge waveguides







Evolution of plasma channel during discharge pulse







Progress with CDWs



- Demonstration of guiding
 - A.Butler et al. PRL 89 185003 (2002)
- Laser machining of capillaries
 - D.A. Jaroszynski *et al. Phil. Trans. Roy. Soc. A* 364 689-710 (2006)
 - S. M. Wiggins *et al. Rev. Sci. Inst.* **82** 096104 (2011).
- Scaling laws for channel properties
 - A. J. Gonsalves et al. PRL 98 025002 (2007)
- Modelling of discharge
 - N.A. Bobrova *et al. PRE* **65** 016407 (2002)
 - B. H. P. Broks *et al. PoP* **14** 023501 (2007)
 - B. H. P. Broks *et al. PRE* **71** 016401 (2005).
 - G. Bagdasarov et al. PoP **24** 053111 (2017).
- Generation of GeV beams
 - W. P. Leemans *et al. Nat. Phys.* **2** 696 (2006)





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A. J. Gonsalves et al. Nat. Phys. 7 862 (2011)



Incorporation of gas jet to control injection

- Channel length increased to 90 mm
 - 4.2 GeV electron beams generated
 - Guiding observed for $n_{\rm e0} \ge 2 \times 10^{17} \, {\rm cm}^{-3}$

- Repetition rate increased to 1 kHz
- Laser heating of channel to decrease n_{e0} and WM
 - N. A. Bobrova *et al. PoP* **20** 020703 (2013)



Hydrodynamically-generated plasma channels





Krushelnick et al. PRL 78 4047 (1997)



- Hydrodynamic expansion
 - C. G. Durfee & H. M. Milchberg, *Phys Rev Lett* **71** 2409 (1993).
 - T. R. Clark & H. M. Milchberg, *Phys Rev E* 61 1954 (2000).
 - V. Kumarappan, *et al. Phys Rev Lett* **94** 205004 (2005).
- Ponderomotive channels
 - K. Krushelnick *et al. Phys Rev Lett* **78** 4047 (1997).

- Colliding gas flows
 - D. Kaganovich *et al. Appl Optics* **54** F144 (2015).





Kaganovich et al. Appl. Opt. 54 F144 (2015)



Plasma channels: hydrodynamic expansion

- Create & heat column of hot plasma
 - ~ 100 ps laser pulse creates and heats plasma
- Expansion into surrounding cold gas / plasma drives cylindrical blast wave
- Plasma channel formed within expanding shell
- Attractive for high repetition rates since "indestructible"
- Extensively studied
 - C. G. Durfee & H. M. Milchberg, *Phys Rev Lett* **71** 2409 (1993).
 - T. R. Clark & H. M. Milchberg, *Phys Rev E* 61 1954 (2000).
 - "Ignitor-heater" : P. Volfbeyn et al. PoP 6 2269 (1999).







- Requirement for rapid collisional heating limits on-axis density to $ne(0) \ge 5 \times 10^{18}$ cm⁻³
- Using clustered gases can reduce this to $ne(0) \ge 1 \times 10^{18} \text{ cm}^{-3}$
 - V. Kumarappan *et al. PRL* **94** 205004 (2005)



0.03 ns

(b) ---- 0.20 ns 0.70 ns 50 1.03 ns 1.70 ns 00 2.37 ns 3.03 ns ••• 3.70 ns Evolution of plasma density (10¹⁸ cm⁻³) in clustered Ar gas jet (113K, 20 bar) 200 300



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 $\mu \mathbf{m}$

OFI-heated hydrodynamic plasma channels

- Optical field ionization gives
 - Hot electrons & cold ions
 - Electron energy controlled by polarization
- ▶ Heating independent of density ⇒ low density channels







OFI-heated hydrodynamic plasma channels

- Optical field ionization gives
 - Hot electrons & cold ions
 - Electron energy controlled by polarization
- ▶ Heating independent of density ⇒ low density channels
- ► HELIOS simulations show channels with $ne(0) \approx 7 \times 10^{17} \text{ cm}^{-3}$





See poster by Chris Arran, Wed 19:30

HELIOS simulations					
п н:	3 × 10 ¹⁸ cm ⁻³				
E_{L} :	50 mJ				
т:	50 fs				
L _{chan} :	600 mm				



OFI-heated hydrodynamic plasma channels

- Optical field ionization gives
 - Hot electrons & cold ions
 - Electron energy controlled by polarization
- ▶ Heating independent of density ⇒ low density channels
- HELIOS simulations show channels with ne(0) ≈ 7 × 10¹⁷ cm⁻³
- Confirmed in preliminary experiments with lens focus



See poster by Chris Arran, Wed 19:30

HEL	IOS simulations
п н:	3 × 10 ¹⁸ cm ⁻³
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Class:	Non-guiding			Waveguides			
Source:	Jet	Cell	Cap. Cell	Vap. Oven	Hollow cap	CDW	Hydro expansion
<i>n</i> e / cm ⁻³							
L/mm							
<i>W</i> _M / μm							
Gas load							
Lifetime							
Rep. rate							
Homog.?							
Ramps?							
Reproduce?							
Long. profile?							
Trans. profile?							
Diag. access							

Yes / Good / High

Not known / Medium

No / Difficult

John Adams Institute for Accelerator Science

- Many factors must be considered when designing the plasma source
- Wide range of solutions have been developed
- Important issues & future challenges
 - Operation at lower densities and over longer lengths
 - Control of longitudinal profile (controlling injection, reduce emittance growth)
 - Improved control of transverse profile (e.g. hollow channels)
 - Long operating life
 - Operation at high repetition rates
 - Reducing gas load to rest of system (affects repetition rate)
 - Reducing/avoiding unwanted background from interaction with structure (e.g. bremsstrahlung)















